

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Takaaki HIGASHIDA et al. :  
Serial No. NEW : **Attn: APPLICATION BRANCH**  
Filed February 20, 2004 : Attorney Docket No. 2004-0276  
METHOD OF MANUFACTURING A :  
SEMICONDUCTOR ELEMENT-MOUNTING :  
BOARD :  
(Rule 1.53(b) Continuation Application  
of Serial No. 09/878,419,  
Filed June 12, 2001)

THE COMMISSIONER IS AUTHORIZED  
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CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents  
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Alexandria, VA 22313-1450

Sir:

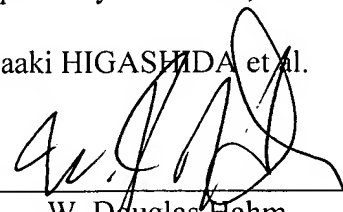
Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 08-179031, filed July 9, 1996, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is of record in grandparent application Serial No. 08/890,009, filed July 8, 1997.

Respectfully submitted,

Takaaki HIGASHIDA et al.

By

  
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